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PATENT

Customer No. 22,852
Attorney Docket No. 5729.0015-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Masayoshi HIROSE et al.) Group Art Unit: 3723
U.S. Patent No. 5,476,414) Examiner: R. Rose
Application No.: 08/993,893)
Filed: December 18, 1997)
For: POLISHING APPARATUS)
Commissioner for Patents
Washington, DC 20231

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TECHNOLOGY CENTER R3700

Sir:

RESPONSE UNDER 37 C.F.R. § 1.114

In reply to the Final Office Action dated April 23, 2002, the period for responding to which has been extended two months to September 23, 2002, by the petition and fee filed herewith, and pursuant to 37 C.F.R. § 1.114, Applicants respectfully request that this application be amended as follows:

IN THE CLAIMS:

Please amend claims 57 and 58, and add claim 59 as follows:

57. (Amended) The method according to claim 56, wherein said support member has a suction hole connected to a vacuum source, so that the workpiece is attracted to said support member when said transferring device is moved toward said workpiece.

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